

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Kim et al. Examiner: Thomas, Toniae M  
Serial No: 10/728,517 Group Art Unit: 2822  
Filed: December 5, 2003 Docket: 8836-203 (IE12204-US)  
For: **CLEANING SOLUTION AND METHOD FOR SELECTIVELY  
REMOVING LAYERS IN A SILICIDATION PROCESS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT TO OFFICE ACTION**

This Amendment is submitted in response to the September 27, 2006 Final Office Action issued by the United States Patent and Trademark Office in connection with the above-identified application. Applicants respectfully request reconsideration of the claim rejections based on the following amendment and remarks.